

PATENT APPLICATION  
Docket No.: 4591-227  
Client Ref. No.: IE10176-US

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Do-Hyung KIM, et al.

Serial No.: 10/083,756 Examiner: Hu, Shouxiang

Filed: February 25, 2002 Group Art Unit: 2811

Confirmation No.: 2262

For: METHOD FOR FORMING LAYER FOR TRENCH ISOLATION  
STRUCTURE

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Responsive to the Office Action, Paper No. 20070202, dated February 8, 2007, please amend the application as follows.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 7 of this paper.